

Notice of References Cited	Application/Control No. 10/628,677	Applicant(s)/Patent Under Reexamination BRILES, SCOTT D.	
	Examiner Siu M. Lee	Art Unit 2611	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,509,836 B1	01-2003	Ingram, Mary A.	340/572.4
*	B	US-4,499,594	02-1985	Lewinter, Sidney W.	704/226
*	C	US-6,147,605	11-2000	Vega et al.	340/572.7
*	D	US-2003/0232600 A1	12-2003	Montgomery et al.	455/67.11
*	E	US-2004/0005863 A1	01-2004	Carrender, Curt	455/41.1
*	F	US-6,456,225 B1	09-2002	Forster, Ian J	342/12
*	G	US-6,914,528 B2	07-2005	Pratt et al.	340/572.1
*	H	US-2003/0137449 A1	07-2003	Vashisth et al.	342/357.08
*	I	US-6,434,194 B1	08-2002	Eisenberg et al.	375/238
*	J	US-6,838,989 B1	01-2005	Mays et al.	340/572.1
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	An impedance-modulated-reflector system, Potentials, IEEE, volume 18, issue 4, Oct-Nov 1999 Pages 29-33
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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